

Attorney Docket No. 081468-0306313
Client Reference: P-1699.000-US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Robrecht De Weerdt

Application No.:	Not Yet Assigned	Confirmation No:	Not Yet Assigned
Filed:	October 9, 2003	Group No.:	Not Yet Assigned
		Examiner	Not Yet Assigned

For: Lithographic Apparatus and Device Manufacturing Method

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: Robrecht DE WEERDT
Citizenship: Belgium
Residence: Minderhoutdorp 33, Hoogstraten 2322, BELGIUM

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: Lithographic Apparatus and Device Manufacturing Method

Docket number assigned to this application: 081468-0306313

Suggested Classification: Class:
Subclass:
Technology Center to which subject matter is assigned:

Total number of drawing sheets: 9

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

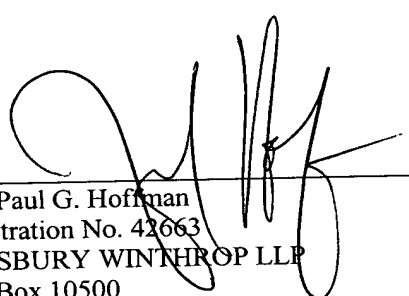
5. Assignee information

The assignee(s) of this application is/are:

ASML Netherlands B.V.
De Run 1110
Veldhoven, NL 5503-LA
THE NETHERLANDS

Extent of interest of assignee in application:

Date: October 9, 2003



Jean-Paul G. Hoffman
Registration No. 42663
PILLSBURY WINTHROP LLP
P.O. Box 10500
McLean, VA 22102
(703) 905-2094
Customer No. 00909

Addendum

Invention Title

Lithographic Apparatus and Device Manufacturing Method